_				
L Number	Hits	Search Text	DB	Time stamp
10	648	(micro nano micromachin\$3 microactuator	USPAT;	2004/05/05
		micromanufactur\$3) and charg\$3 with	EPO; JPO	11:46
		transfer\$4 same (movable rotat\$4	,	
		translat\$3)		
11	22	(micro nano micromachin\$3 microactuator	USPAT;	2004/05/05
		micromanufactur\$3) same charg\$3 with	EPO; JPO	11:49
		transfer\$4 same (movable rotat\$4	510, 010	11.15
		translat\$3)		
12	16	(micrometer nanometer micromachin\$3	USPAT;	2004/05/05
12	10	microactuator micromanufactur\$3) same	EPO; JPO	13:48
		charg\$3 with transfer\$4 same (movable	EPO, UPO	13.40
		rotat\$4 translat\$3)		
13	309	(micrometer nanometer micromachin\$3	IICDAM -	2004/05/05
13	309		USPAT;	2004/05/05
		microactuator micromanufactur\$3) and	EPO; JPO	12:22
		charg\$3 with transfer\$4 same (movable		
1.4	1.0	rotat\$4 translat\$3)	*****	0004/05/05
14	19	(micromotor micromachin\$3 microactuator	USPAT;	2004/05/05
		micromanufactur\$3) and charg\$3 with	EPO; JPO	13:47
a to partie and to consider	وموالم المحاور المراجع	rransfer\$4 same (movable rotat\$4	والمسوم المدينية برايا	Secretary of
1		translat(3)	The same to the same of the sa	
17	6434	electrostatic with (machine generator)	USPAT;	2004/05/05
1.0		and (translat\$3 movable rotat\$4)	EPO; JPO	13:47
18	44	(micromotor micromachin\$3 microactuator	USPAT;	2004/05/05
	1	micromanufactur\$3) and (electrostatic	EPO; JPO	13:47
		with (machine generator) and (translat\$3		
		movable rotat\$4))		
19	273	(micrometer nanometer micromachin\$3	USPAT;	2004/05/05
		microactuator micromanufactur\$3	EPO; JPO	15:08
		micromotor) and (electrostatic with	11	
		(machine generator) and (translat\$3		
		movable rotat\$4))		
41	55	(micrometer nanometer micromachin\$3	USPAT;	2004/05/05
		microactuator micromanufactur\$3	EPO; JPO	15:59
		micromotor microelectronic) and charge		
		same electrostatic with transfer\$4 same		
1.		(movable translat\$4 rotat\$4)		
42	30	micromover	USPAT;	2004/05/05
			EPO; JPO	15:59
-	1	(microfabricated adj1 van).ti.	USPAT;	2004/03/16
1 2 2 2	سدمعتي	2.	US-PGPUB	
	3329	tionsfer\$4 adjl charge	USEMI:	2007/07/17
			US-PGPUB	21:10
-	22	transfer\$4 adj1 charge and mov\$5 adj1	USPAT;	2003/07/11
		component and posit\$4	EPO; JPO	21:11
	15	4014605.URPN.	USPAT	2003/07/11
				21:13
-	1	5557596.pn.	USPAT;	2003/07/14
			EPO; JPO	10:15
-	5	("4427886" "4534016" "4600839"	USPAT	2003/07/14
		"4760567" "5402410").PN.		10:08
	23	5557596.URPN.	USPAT	2003/07/14
				10:09
-	1	source and drain and electrostatic and	USPAT;	2003/07/14
		tribocharge and friction\$4	EPO; JPO	10:17
-	538	source and drain and electrostatic and	USPAT;	2003/07/14
		friction\$4	EPO; JPO	10:25
-	149	(source and drain and electrostatic and	USPAT;	2003/07/14
		friction\$4) and micro	EPO; JPO	10:18
-	282	source and drain and electrostatic and	USPAT;	2003/07/14
		friction\$4 and transfer\$3 and charge	EPO; JPO	10:26
-	285	source and drain and electrostatic and	USPAT;	2003/07/14
		friction\$4 and transfer\$4 and charge	EPO; JPO	10:51
-	106	(source and drain and electrostatic and	USPAT;	2003/07/14
		friction\$4 and transfer\$4 and charge) and	EPO; JPO	10:26
		electron	,	
-	99306	source and drain and transfer\$4 and	USPAT;	2003/07/14
	22300	charge protrusion and mov\$5	EPO; JPO	10:52
-	291	source and drain and transfer\$4 and	USPAT;	2003/07/14
		charge and protrusion and mov\$5	EPO; JPO	11:22
L	ا ــــا			1]

-	2	((tribocharging triboelectric) same	USPAT;	2004/03/17
		material and (transferring moving moveable)) and 323/\$.ccls.	EPO; JPO	16:05
	0	((tribocharging triboelectric) same	HCDAT.	2004/03/17
	Ū	material and (transferring moving	USPAT; EPO; JPO	2004/03/17 16:05
		moveable)) and 313/\$.ccls.	ELO, UPO	10.03
-	0	((tribocharging triboelectric) same	USPAT;	2004/03/17
		material and (transferring moving	EPO; JPO	17:30
		moveable)) and 363/\$.ccls.	шо, ото	17.30
-	6	((tribocharging triboelectric) same	USPAT;	2004/03/17
		material and (transferring moving	EPO; JPO	17:30
		moveable)) and 369/\$.ccls.	210, 010	17.30
-	430	micro\$1meter adj scale	USPAT;	2004/04/30
			EPO; JPO	15:56
-	1	(micro\$1meter adj scale) and moveable	USPAT;	2004/04/30
		with (device component)	EPO; JPO	14:36
-	29	(micro\$1meter adj scale) and mov\$5 with	USPAT;	2004/04/30
		(device component) and charge	EPO; JPO	14:36
-	124	("3150442" "3538744" "3669881"	USPAT	2004/04/30
		"3738759" "3915652" "3921916"		14:40
		"4007464", "4056324", [3092166"		
	- 6	1."4209696" "-"4356722"	90	- 17 184 -NEW WILLEY
, T		"4369664" "4403234" "4437103"		
		"4459267" "4480259" "4489233"		
		"4490728" "4590482" "4593728"	1	
		"4683042" "4708782" "4728392"	1	
		"4733823" "4842701" "4879097"		
		"4891120" "4908112" "4983038"		
		"4999493" "5015845" "5110745"	1	
		"5126022" "5132012" "5162650"		l i
		"5180480" "5182366" "5245185"		
		"5269900" "5283036" "5294426"		ŀ
		"5296114" "5296375" "5302533"		
		"5304487" "5306621" "5316680" "5328578" "5321150" "5322401"		
	A	"5328578" "5331159" "5332481" "5334310" "5338427" "5349186"		
		"5334310" "5338427" "5349186" "5374834" "5376252" "5387329"		
		"5401376" "5401963" "5415841"		
		"5421980" "5423964" "5427946"		
		"5429734" "5431807" "5445324"		l i
1 N		"5453185" "5481110" "5486335"		1
		"5493115" "5495108" "5498392"		
	1	~"5591885" "5%6\893" "5±05832# /#	1	Manager and the state of the st
		"5512131" "5512451" "5523566"		
		"5536939" "5541408" "5563639"		
		"5572023" "5608217" "5640010"		
	*	"5641400" "5644131" "5647979"		
		"5652427" "5705813" "5716825"		
		"5747815" "5750988" "5779868"		
		"5789746" "5800692" "5804022"		
	-	"5856082" "5872010" "5876957"		
		"5877495" "5917184" "5917185"		
		"5969351" "5969353" "5972187"		
	ļ	"5993633" "5994696" "6005245"	1	
		"6007775" "6032876" "6060705"		
	ļ	"6066848" "6068749" "6110343"		
		"6114693" "6171875" "6245227"		
	ļ	"6394942" "6417510" "6432311"		
	İ	"6454938" "6461516" "6462337"		
		"6464866" "2001/0001455"		
		"2001/0001460" "2002/0123153"		
		"2002/0158027").PN.		
-	1009	(micro\$1meter microelectronic	USPAT;	2004/04/30
		microactuator microfabricat\$3	EPO; JPO	16:06
		micromanufactur\$3) same (device element		
	ļ	part component) and transfer\$3 with		
		(species charge)	}	

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-	225	((micro\$1meter microelectronic	USPAT;	2004/04/30
		microactuator microfabricat\$3	EPO; JPO	16:07
		micromanufactur\$3) same (device element		
		part component) and transfer\$3 with		
		(species charge)) and source and drain		
-	143	(((micro\$1meter microelectronic	USPAT;	2004/04/30
		microactuator microfabricat\$3	EPO; JPO	16:09
		micromanufactur\$3) same (device element		
		part component) and transfer\$3 with		
		(species charge)) and source and drain)		
i		and (spin\$4 mov\$4 translat\$4 rotat\$4)		
-	17	(micro nano) with (scale size) and charge	USPAT;	2004/05/04
		with (drain source) with transfer\$4	EPO; JPO	11:27
	2	electronic with charge with (drain	USPAT;	2004/05/04
		source) with transfer\$4 and movable with	EPO; JPO	11:30
		(part device component)	110, 010	11.50
	24		USPAT;	2004/05/04
	2.	source) same transferring and (transfer\$4	EPO; JPO	11:31
		movable) with (part device component)	EFO, UPO	11.31
_	2951	charge with transferring with device	USPAT;	2004/05/04
	2551	charge with transferring with device	I .	
18 44	. 29	i(charge with transferring with device)	EPO; JPO	18:20
	- 		GSPAT:	
1		and (movable translat\$4) with (component part disk plate member)) and scale	EPO; EPO	18:14
	17	3767983.URPN.	Lianan	0001/05/01
	17	3/6/963.URPN.	USPAT	2004/05/04
	153	/		18:16
-	133	(charge with transferring with device)	USPAT;	2004/05/04
		and (movable translat\$4) with (component	EPO; JPO	18:26
	846	part disk plate member)		2004/05/04
	046	charge with transfer\$4 with generat\$3	USPAT;	2004/05/04
	1.0	same semiconductor	EPO; JPO	18:25
	16	, 5	USPAT;	2004/05/04
		same semiconductor) and (micro nano	EPO; JPO	18:25
	1.5	smaller) near (scale size)		
	15.	(charge with transfer\$4 with generat\$3	USPAT;	2004/05/04
		same semiconductor) and (micrometer	EPO; JPO	18:25
		nanometer smaller) near (scale size)		0004/05/04
	0	(charge with transfer\$4 with generat\$3	USPAT;	2004/05/04
		same semiconductor) and (micrometer	EPO; JPO	18:25
1 1	202	nanometer) near (scale size)		
	393	charge with transfer\$4 with generat\$3 and	USPAT;	2004/05/04
	3.0	(micrometer nanometer)	EPO; JPO	18:38
	···18	,	USPAT:	1 2004/05/04
		and (micrometer nanometer)) and (movable	EPO; JPO	18:27
		translat\$4) with (component part disk		
	640	plate member)		
1	642	,	USPAT;	2004/05/04
	120	(micrometer nanometer)	EPO; JPO	18:38
_	132	charge with transfer\$4 same generat\$3 and	USPAT;	2004/05/04
	1.0	(micrometer nanometer) with (scale size)	EPO; JPO	18:52
_	. 16	charge with (source drain) same	USPAT;	2004/05/04
		transfer\$4 same generat\$3 and (micrometer	EPO; JPO	18:54
		nanometer) with (scale size)		
_	169	charge with (source and drain) same	USPAT;	2004/05/04
1 .		transfer\$4 same generat\$3	EPO; JPO	18:55